J-PARC MLF MUSE muon beams

J-PARC MLF Muon Section/KEK IMSS

Yasuhiro Miyake

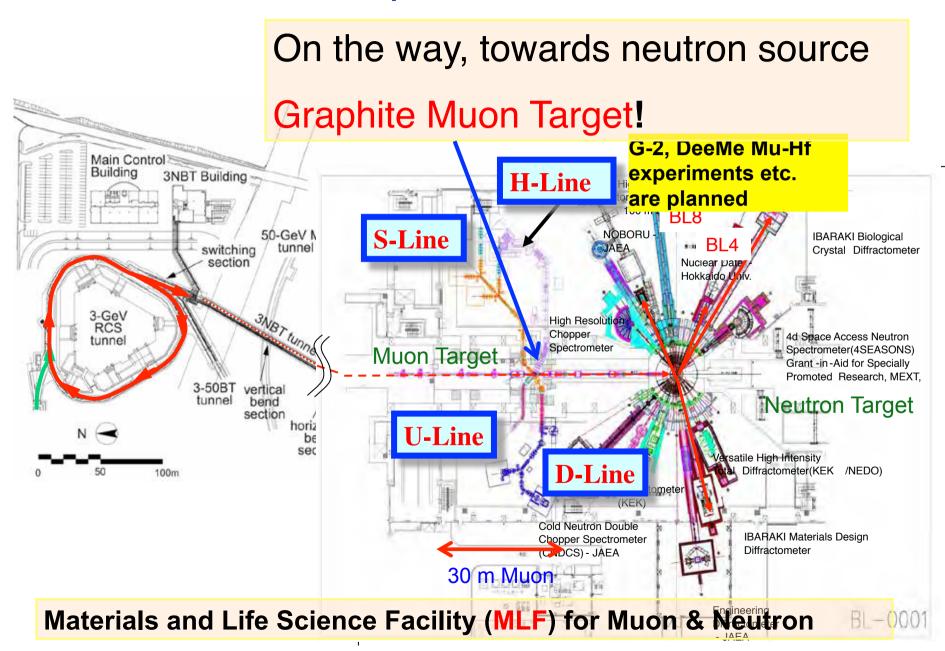
D-Line In operation

U-Line Commissioning started!

S-Line Partially constructed!

• H-Line Partially constructed!

Proton Beam Transport from 3GeV RCS to MLF



Edge-cooling Graphite Fixed Target

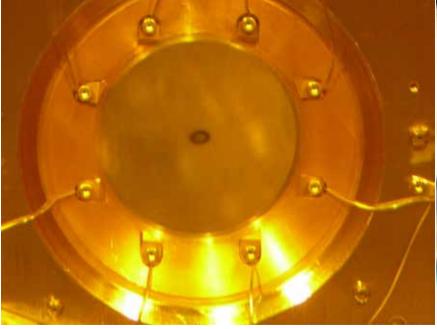


Rotating Graphite
Target
From January 2014!

At Present!

Will be changed in Summer 2013!

Investigated during shut-down!





Rotating Target



Fixed Target

S-Line

Surface $\mu^+(30 \text{ MeV/c})$

For material sciences

H-Line

Surface μ^+ For HF, g-2 exp. e- up to 120 MeV/c For DeeMe μ^- up to 120 MeV/c For μ CF

Muon Target

U-Line

Ultra Slow $\mu^+(0.05\text{-}30\text{keV})$

For multi-layered thin foils, nano-materials, catalysis, etc

D-Line

Surface $\mu^+(30 \ MeV/c)$ Decay $\mu^+/\mu^-(up \ to \ 120 \ MeV/c)$

Users' RUN, in Operation



4月2日朝·5

D-Line, since Sep., 2008

The world-most intense pulsed muon beam achieved at J-PARC MUSE

At the J-PARC Muon Facility (MUSE), the intensity of the pulsed surface muon beam was recorded to be 1.8 x 10⁶/s on November 2009, which was produced by a primary proton beam at a corresponding power of **120 kW** delivered from the Rapid Cycle Synchrotron (RCS). The figure surpassed that obtained at the Muon facility of Rutherford Appleton Laboratory in the UK, pushing MUSE to the world frontier of muon science. It also means that the unprecedentedly high muon flux of 1.5 x 10⁷/s (surface muons) will be achieved at MUSE when the RCS proton beam power reaches the designed value of 1 MW within a few years

(第3種郵便物廳司) 2010年(平成22年)3月16日(火曜日)

世界最高強度のミューオン発生が確認されたJ-PA RCの実験施設。左から延びるのがミューオンの通り 道だ(J-PARCセンター提供。建設中の撮影)

国 1-PARC「ミューオン」発生装置 リーPARC「ミューオン」発生装置 第無村の大強度陽子加速 子。磁気に敏感に反応す 装置が昨年暮れ、世界最高 を、極めて高い精度で測が、施設を運営するJーP はじめ、超電導素材、燃が、施設を運営するJーP はじめ、超電導素材、燃が、施設を運営するJーP はじめ、超電導素材、燃が、施設を運営するJーP はじめ、超電導素材、燃が、施設を運営するJーP はじめ、超電導素材、燃が、施設を運営するJーP はじめ、超電導素材、燃が、施設を運営するJーP はじめ、超電導素材、燃が、施設を運営するJーP はじめ、超電導素材、燃が、施設を運営するJーP はじめ、超電導素材、燃流を発揮すると明符されて、

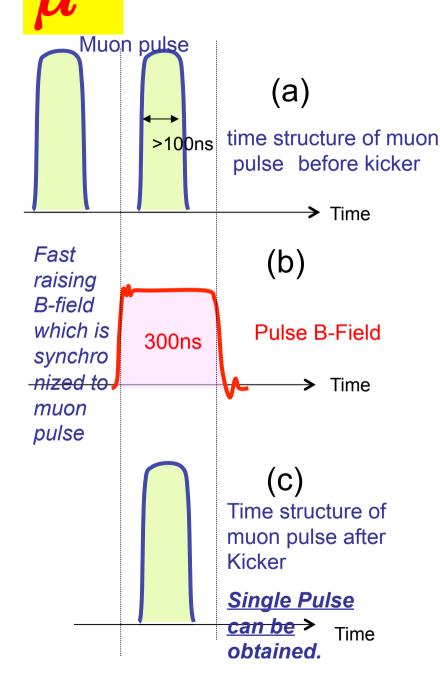
We achieved World strongest pulsed surface muon beam at J-PARC MUSE D1&D2 area even with 120 kW intensity. on November,10th 2009

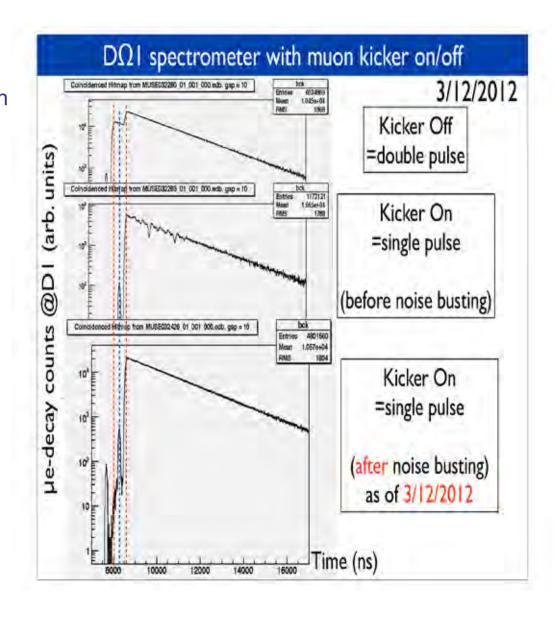
J-PARC 実験で成功

を持ちるととを確認。来でが発生していることを確認。来でした。 10日の運転では勝子ビーのよ出力を3000kgによ異、個では、第二オン装置に導き、たさせ、ミュオン装置に導き、たさせ、ミュオン装置に導き、

の定常 る、世界最高強度パルスミンが確認 を確認 来してきている。また3 学ど - 00 が3運転時では約18万 学ど - 00 が3運転時では約18万 学ど - 00 が3運転時では約18万 学ど - 2 当たり約3万個を上回 を確認 来してきている。また3 学ど - 2 当たり約3万個を上回 を確認 来してきている。また3

Muon Kicker System







Top loading Dilution Refrigerator

- Brought from KEK-MSL
- 25mK was achieved at D1 area on 4/30.
- It takes 3 days until achieving the lowest temperature.
- It takes 8-12 hours to exchange a sample.

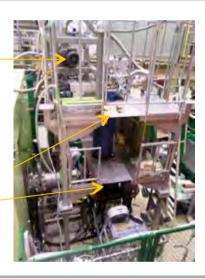


Gas Handling

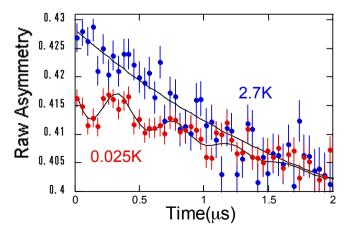
Liq.He vessel

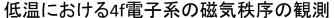
Manipullation (∼3m)

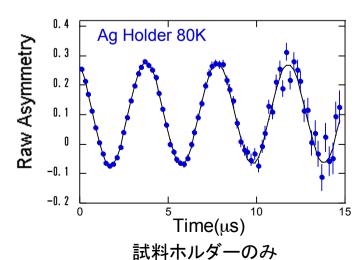
D1 Spectrometer

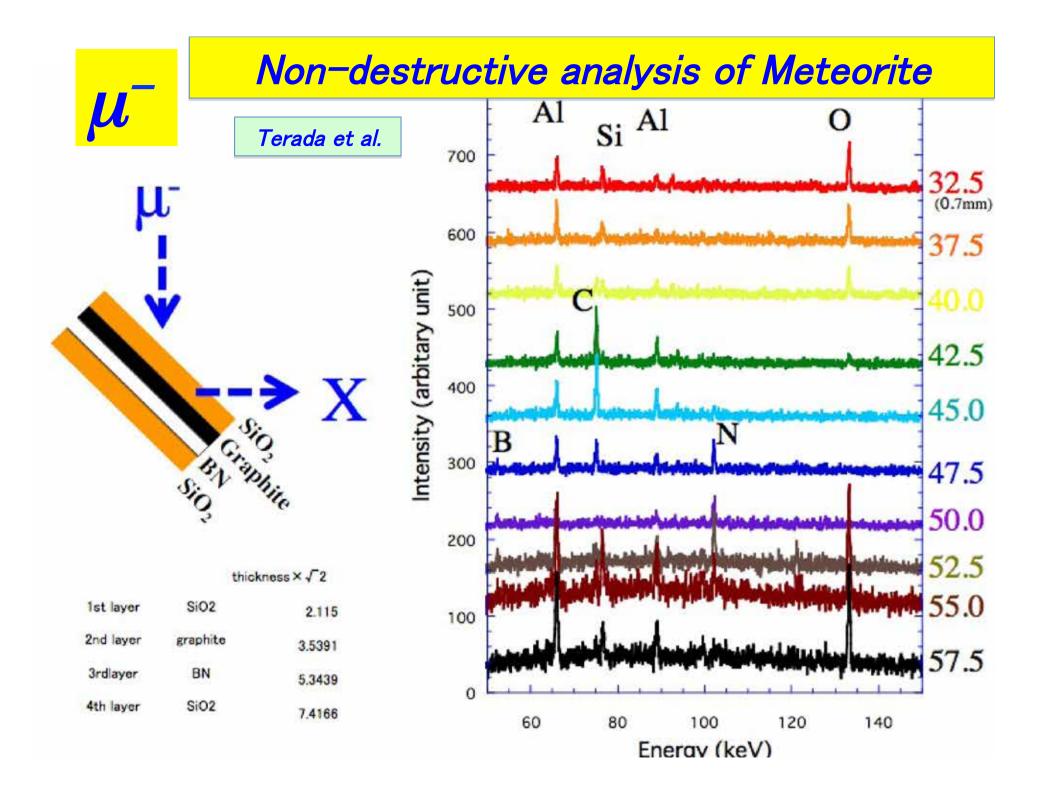












Studies explored at MUSE D-Line

Either Surface muon (μ^+) or Decay muon (μ^+/μ^- up to 120 MeV/c) available!

- 1. Solid State Physics (Magnetism Superconductor)
 - 1. μ SR Study of Organic Antiferromagnet β '-(BEDT-TTF)₂IBrCl
 - 2. µSR in Ironprictide superconducto Phys. Rev. Lett. 103 027002←The first PRL @J-PARC
 - 3. µSR evidence for magnetic ordering in CeRu₂Al₁₀ J. Phys. Soc. Jpn. At May, 2010
 - **4.** novel phase transition in **f-electron system** high-order "multipole" ordering *Phys.Rev. B* 82, 014420 (2010), *Phys. Rev. B* 84, 064411 (2011). *J. Phys. Soc. Jpn.* 80(2011)SA075, *J. Phys. Soc. Jpn.* 80, 113703 (2011). "*J. Phys. Soc. Jpn.* 80, 033710 (2011).
 - 1. Ba₂IrO₄: A novel spin-orbit Mott insulating quasi-2D antiferromagnet, *Phys.Rev. B83*, *155118* (2011)
- 2. Material Science (Li Batteries, Alloy, Voids)
 - 1. Li_xCoO₂(Toyota) *Phys.Rev. B* 82,224412 (2010), *Phys.Rev. B*84 054430 (2011)
 - 2. CaFe₂O₄-type NaMn₂O₄ and LiMn₂O₄
 - 3. Li Diffusion in Li ion conductor
 - 4. Pre-martensitic phenomena of thermo elastic martensitic transformation in NiTi alloys studied by muon
 - 5. μSR in Finemet → contribution towards J-PARC accelerator!
- 3. Physical CHemistry
 - 1. Investigation of molecular effect in the formation process of muonic atom
 - 2. Mu(µ+e-) formation mechanism in condensed matters
- 4. Particle Physics
 - 1. $\mu^- + A(Z,N) \rightarrow e^- + A(Z,N)$ rare decay
- 5. Non-destructive analysis, Radiography
 - 1. Koban, Old coin J. Phys.: Conf. Ser.s 225 (2010) 012040, Bull. Chem. Soc. Jpn. Bull. Chem. Soc. Jpn. (2012)
 - 2. Muon Radiography
- 6. Beam Development
 - 1. Slicer J. Phys.: Conf. Ser. 225 012012(2010)
 - 2. Ultra Slow Muon

U-Line

Dedicated to Ultra Slow Muon

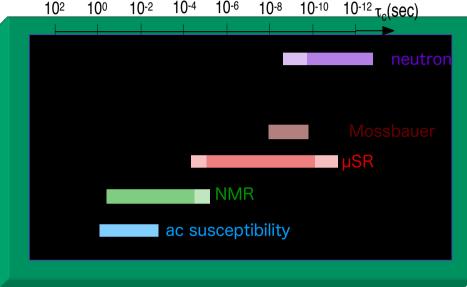
more than 10 times intense than D-Line

First goal of U-Line:
Surface muon source that produce Ultra Slow muon
(E= 0.05 eV – 30 keV) with high intensity and high luminosity.

Motivation

Positive Muons (µ⁺) very powerful tool

- •As a probe for microscopic magnetism
- As a light isotope of H, D and T,its Diffusion and Reaction
- •Specific Time Scale (µs order)



Strong Requirement for *Ultra Slow Muon Source*

- *Study Nano-science(Interfaces or multi-layered film)
- *Surface Chemistry-Catalysis on nano-particle

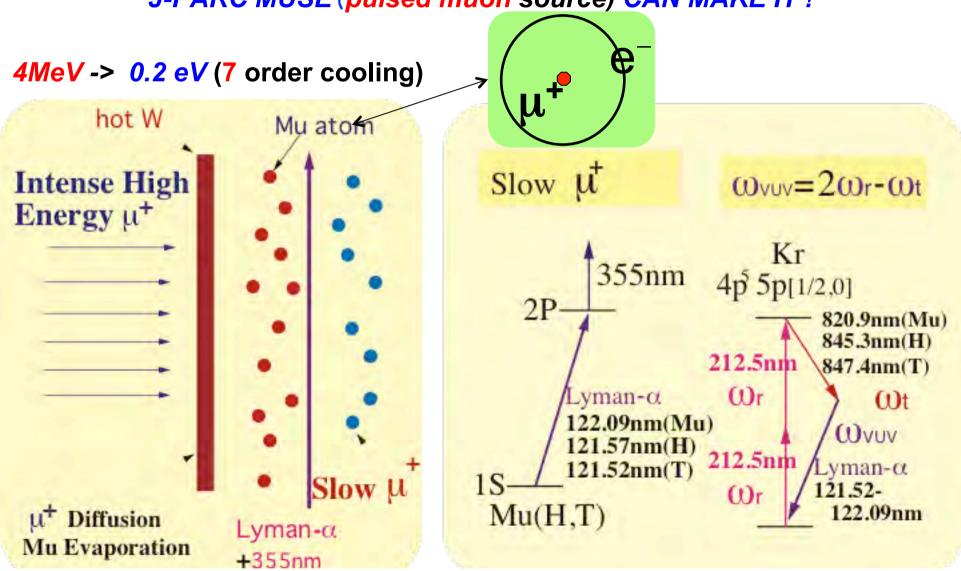
Cooling techniques to obtain **Slow Muon** Beam

- •Slowing down through solid Ar or N_2 at PSI
- *Laser Resonant Ionization of Mu at KEK, RIKEN-RAL&J-PARC

Concept of ultra slow μ⁺ generation by laser resonant ionization of thermal Mu from hot tungsten

Can be realized by synchronizing intense pulsed muon and pulsed laser

J-PARC MUSE (pulsed muon source) CAN MAKE IT!



Ultra-slow Muon HISTORY

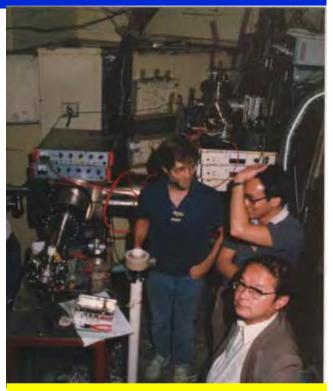
STEP1: Production of Thermal Muonium in vacuum (~1985) by Mills, Imazato, Nagamine et al. & Matsushita, Nagamine(Pt)

STEP2: Resonant Ionization of thermal Muonium by 1s-2s excitation(~1987)(QED confirmation) By Chu, Mills, Kuga, Yodh, Miyake, Nagamine et al.

STEP3: Ultra-slow Muon Project @KEK (1990-1998) by Miyake, Shimomura, Birrer Nagamine, et al.

STEP4: Ultra-slow Muon Project @理研RAL (1999~) by Bakule, Matsuda, Miyake, Shimomura, Nagamine et al.

STEP5: High-intensity Ultra-slow Muon @J-PARC (2010-) Present project



STEP 2 Thermal Mu1s-2s resonant excitation

•The first successful extraction of Ultra-slow Muon!

•consistent with QED

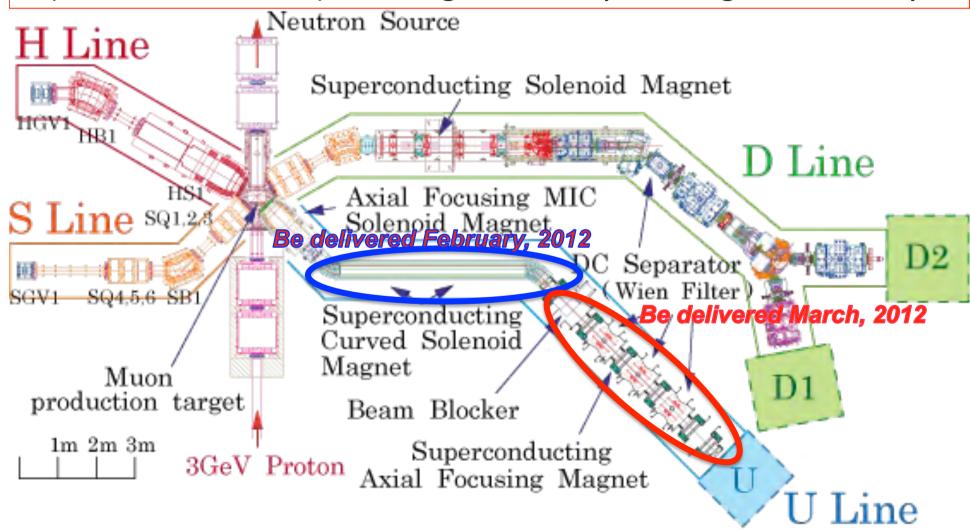
expectation within 300MHz

By S. Chu, Nobel prize (1997). Now Secretary of US-DOE.

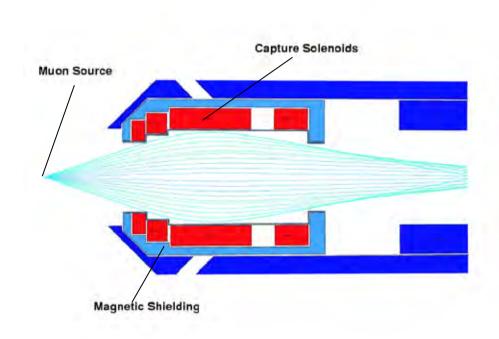
U-Line

 5.0×10^8 /s surface muons, 20 times more intense than D-line which is the strongest at present!

Dedicated beam line to produce Ultra Slow muon (E=0.05-30 keV) with high intensity and high luminosity.



Normal Conducting MIC Capture Solenoid

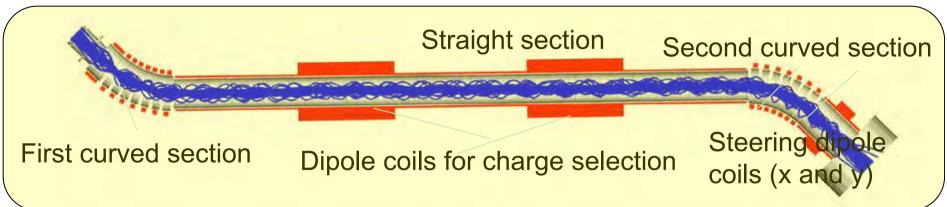


Maximum current	1500A
Peak central field	0.3T
Coolant	130 l/s
Muon capture rate	5x10 ⁸ μ ⁺ /s @ 30 MeV/c
Solid angle acceptance	400 mSr (±20° initial angle, ~10 times larger)



Due to the high level of exposure to radiation, the solenoids are wound with radiation-resistant mineral insulation cables(MIC).

Superconducting Curved Transport Solenoid under fabrication @Toshiba deep collaboration with KEK cryogenic group!



Cooled by Five Gifford-McMahon (GM) refrigerators

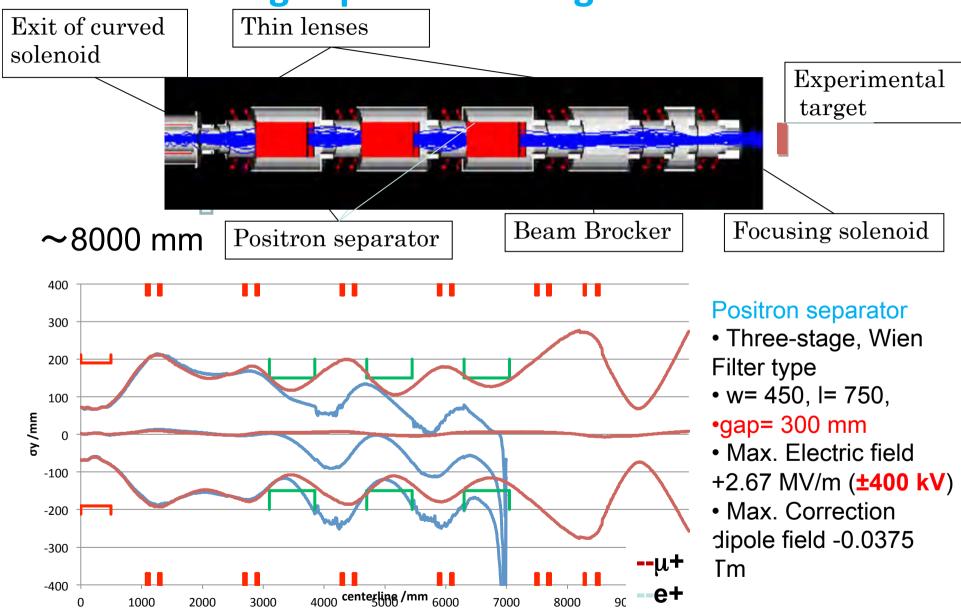


Should be delivered Oct.,2011, but Postponed to June. 2012



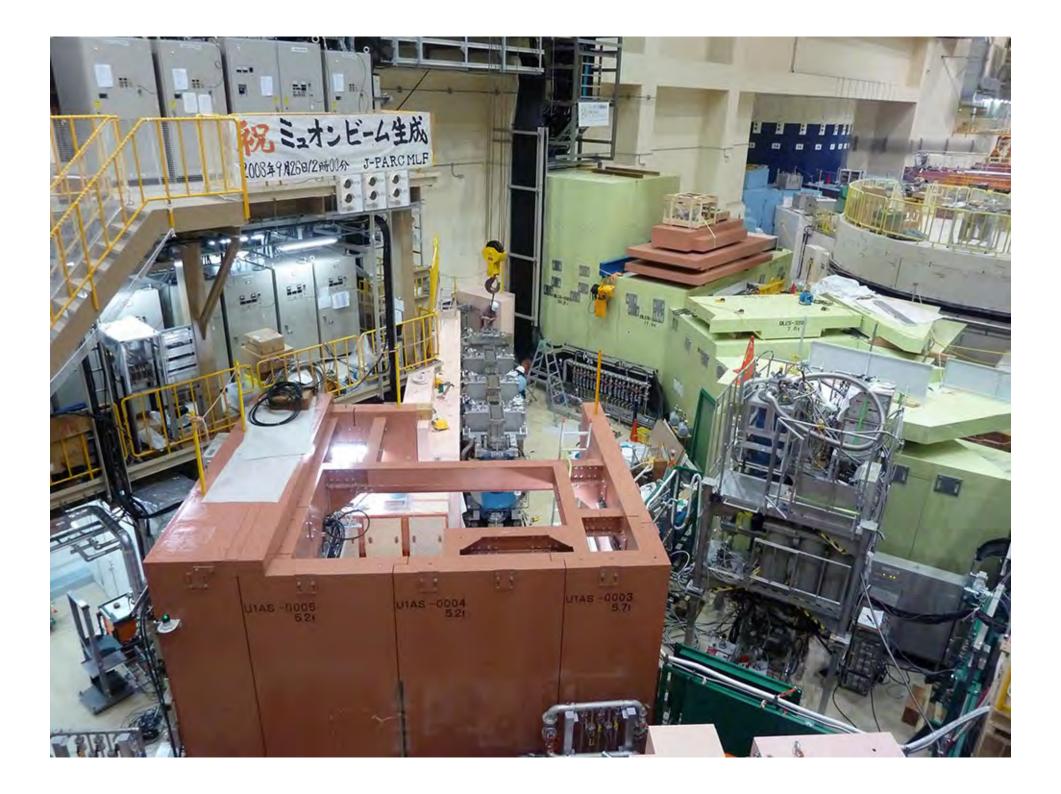


Axial Focusing superconducting solenoids



Funded, Many thanks to KEK Directors & J-PARC Director





Surface μ^+ stopping on W, Commissioning Beam size and focal length from Oct. 18th,

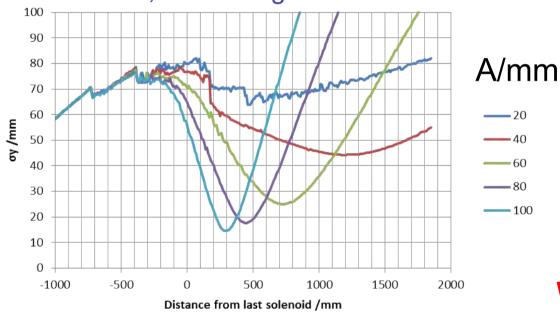
Beam size and focal length

Dependence of current density

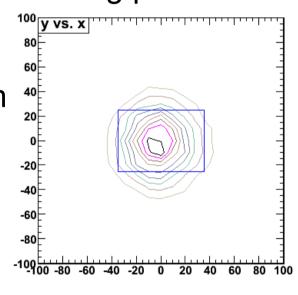
of the last coil

 σ = 18 mm, Focal length 460 mm





Beam profile at the final focusing point (700mm)

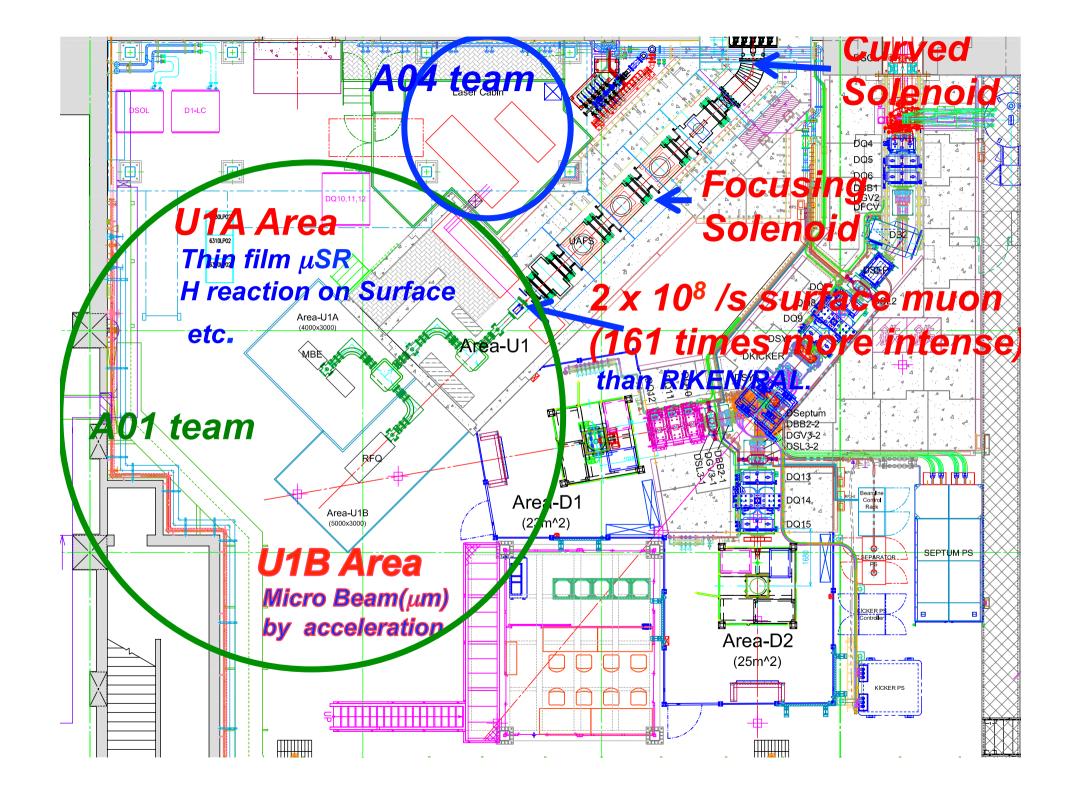


W Target (70 x 40 mm²)

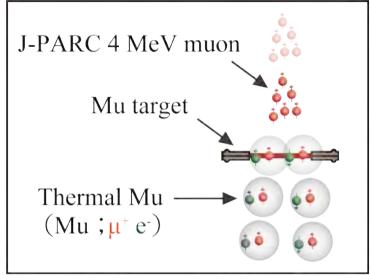
Intensity: $2 \times 10^8 \ \mu^{+}/s$, on W (70 x 40 mm²) (@1 MW)

Intensity: 1.2 x10⁶ (\rightarrow 0.5 x 10⁶) μ ⁺/s, on W (40 x 35 mm²)@RIKEN-RAL

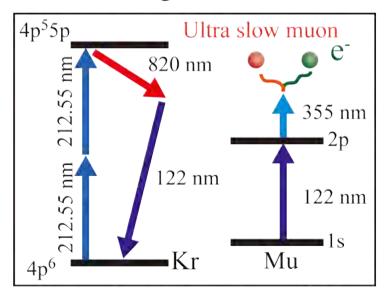
1.2 x10⁶/s is surface μ^+ arriving at Port3, could be less than 0.5 x 10⁶/s stopping on W



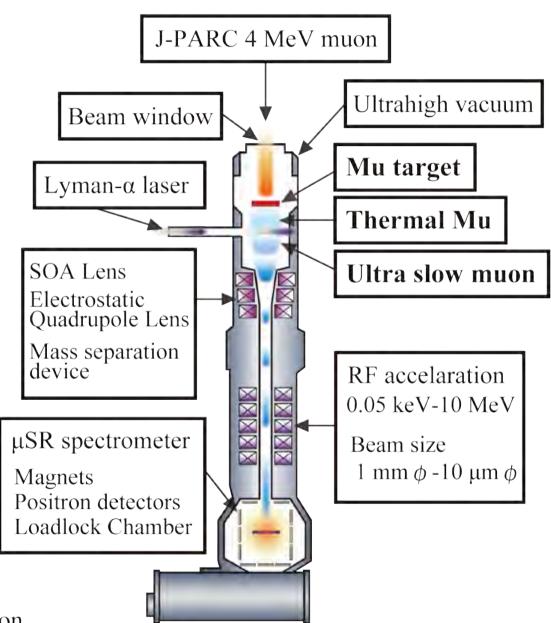
A01: Generation of Ultra Slow Muons



Mu generator



Lyman-α laser generation and Mu dissociation by laser resonant ionization method



ULTA SLOW MUON GENERATION

Grants-in-Aid; Frontier of Materials, Life and Elementary Particle Science Explored by Ultra Slow Muon Microscope Lead by Prof. E. Torikai

A01:Ultra Slow Muon Microscopy & Microbeam (Y. Miyake)

A02: Spin Transport and Reaction at Interface (E. Torikai)

A03: Heterogeneous correlation of electrons over the boundary region between bulk and surface (R. Kadono)

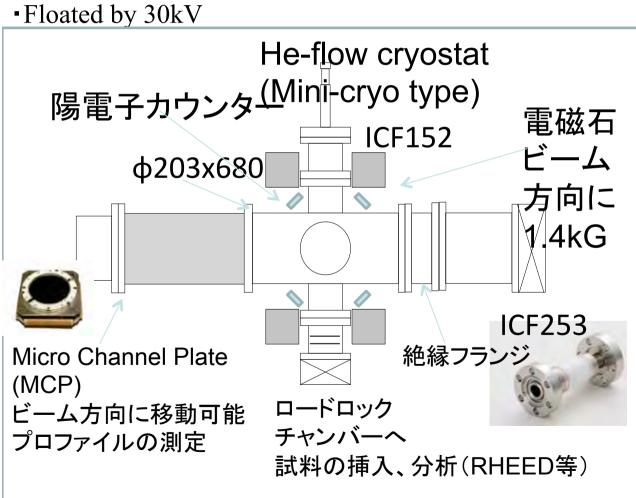
A04:Ultra Cold Muon beam (M. Iwasaki)

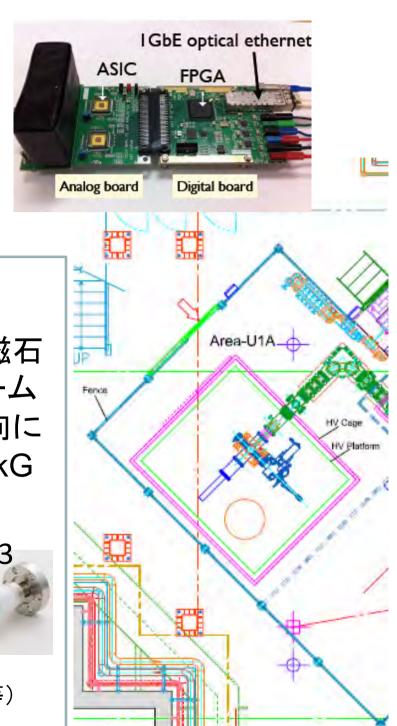


Spectrometer

Specification of Spectrometer(1st stage)

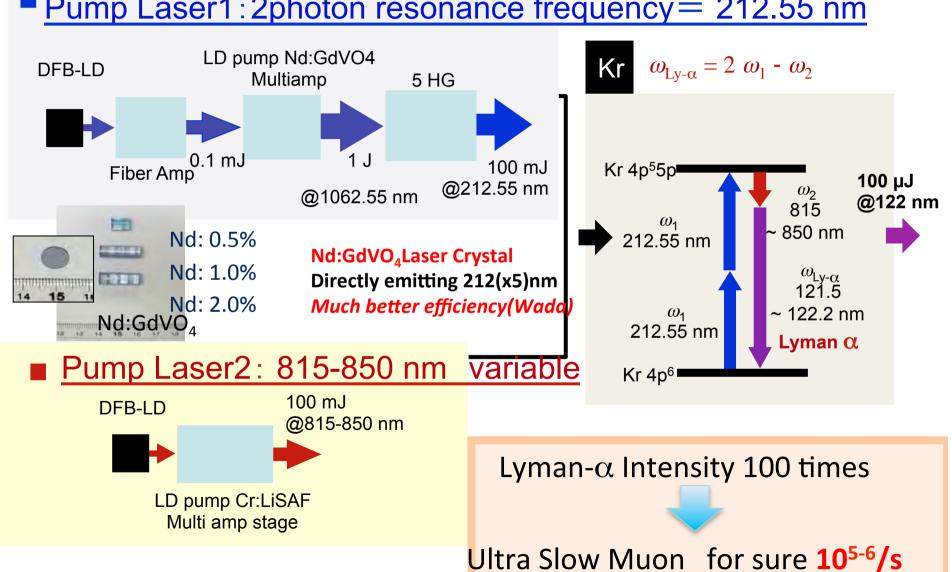
- Magnetic Field0-1400G (Normal conducting)
- •Temperature 10-15K以上 (He flow cryostat)
- Vacuum (10-8Pa)
- •e⁺ counters, MPPC (256ch)





Laser Diagram

Pump Laser1:2photon resonance frequency = 212.55 nm



S.WADA, N. Saito & M.IWASAKI RIKEN

Expected Yield of Ultra Slow Muon

20 slow muons/second at RIKEN-RAL→J-PARC, MUSE

- 1) Repetition Rate
 25 Hz (At RIKEN-RAL 50 Hz) factor 2 times (1.5)
- 2) Surface Muon Yield by **Super Omega Channel** $2.0 \times 10^8 / s / 1.2 \times 10^6 / s (RIKEN-RAL) =$ **161**times (400)
- 3) Lyman- α Intensity by Laser Development

71 μ J/p / <1 μ J/p (RIKEN-RAL) ~ 100 times

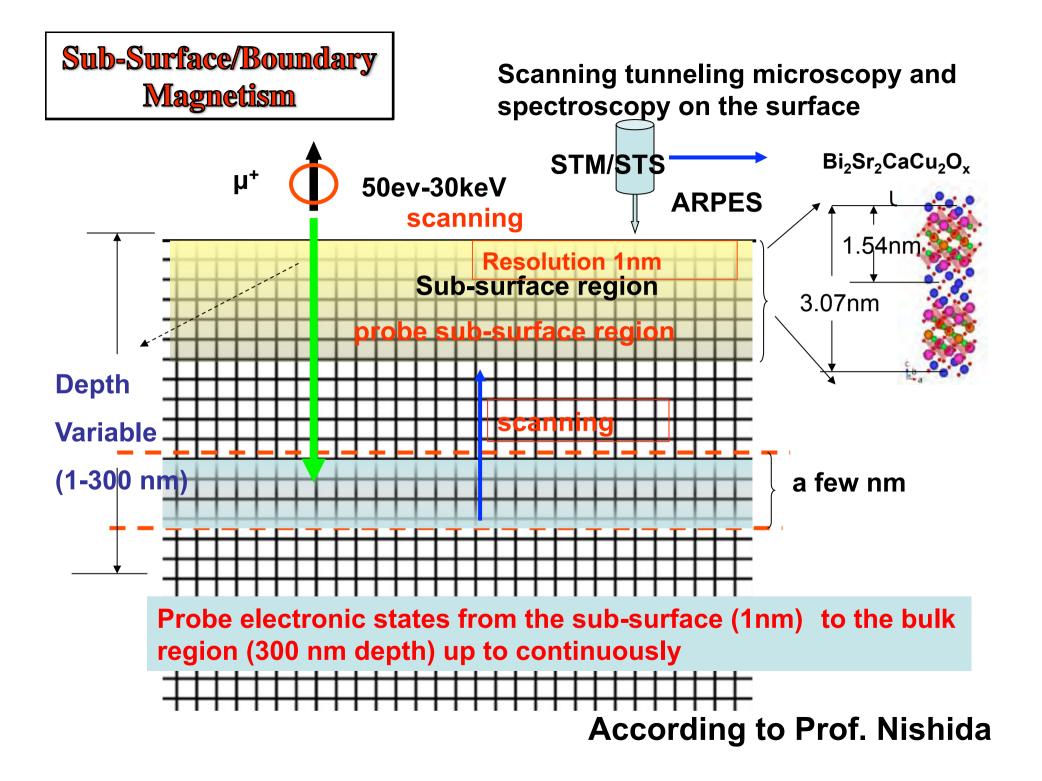
Our Goal of Ultra Slow Muon Yield is

 $20 /s \times 2 \times 161 \times 100 = 0.6 \times 10^6 /s (Maximum)$

Riken-RAL Slow Muon Intensity Started with realistically, 103/s!

Sub-Surface/Boundary Magnetism

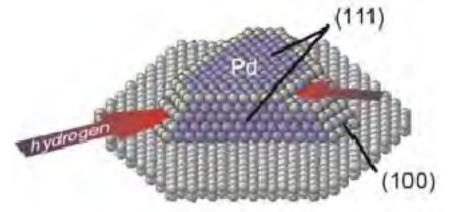
utilizing variable implantation depth (1 nm to 300 nm)



Surface/Sub-Surface H chemistry

Surface/Sub-Surface H chemistry

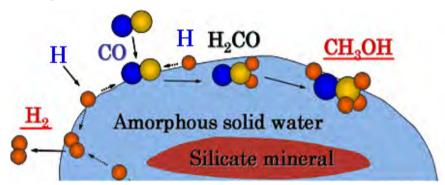
H reaction on the nano Surface quite different from bulk



- Surface H → Isomerization
- Adsorbed H—— Hydrization

M. Wilde et al., ACIE 47 (2008) 1.

Chemical Evolution in Cosmic May occur on the surface of ICE



Main Cast is H
CO + 3H
$$\rightarrow$$
 CH₃O
H + H \rightarrow H₂

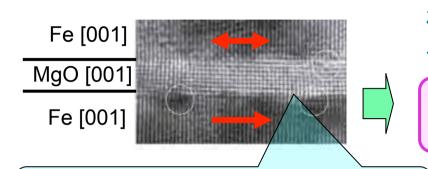
N. Watanabe, A. Kouchi, PSS 83 (2008) 439

- Clarify Electronic state of H on the surface
 - Role of the surface H on Ice/Cluster
 - Diffusion Constant of H

According to Prof. Fukutani

A02 Spin Transport and Reaction at Interface

Spin direction of the Ultra Slow Muon can be easily controlled by Spin Rotator

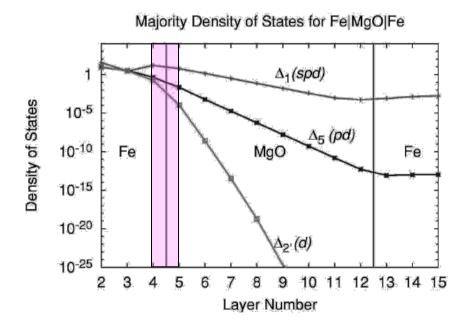


磁気トンネル接合には絶縁体・強磁性体界面のスピン状態の理解が重要

- Extension towards half metal etc.
- ◆ Spin Implantation to semiconductor

Spin implantation depends upon Atomic spin state on the boundary

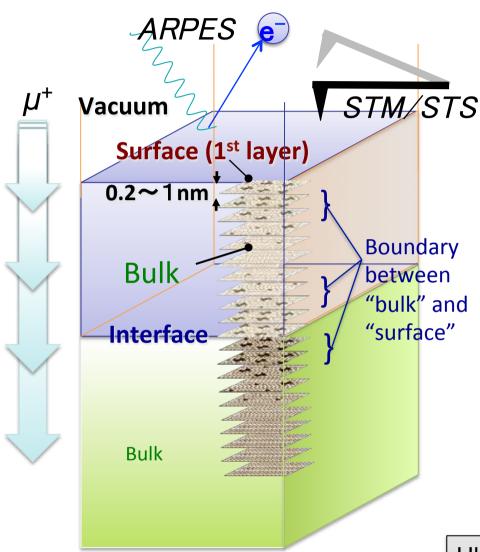
Observing spin state on the boundary between Ferro/insulator



According to Prof. Yoshino

Butler et al. PRB 63, 056614 (2001).

A03: "Heterogeneous electronic correlation at sub-surface & interface"



Remarkable difference in the electronic property between surface and bulk

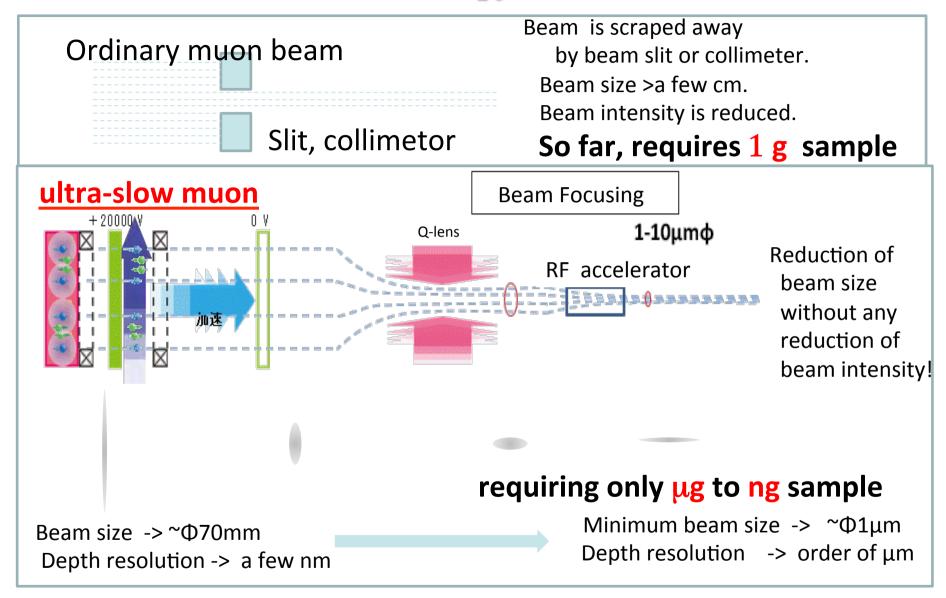
- Breakdown of inversion (mirror)
 symmetry at surface/interface →
 "Recovery of orbital angular momentum"
 near the surface
- Spatial constraint over the motion of electrons → "Enhancement of quasitwo-dimensional character and associated change in the electronic state

...Novel electronic property ("heterogeneous electronic correlation") may be realized on the hetero-structure composed of transition metal compounds that are subject to strong electronic correlation.



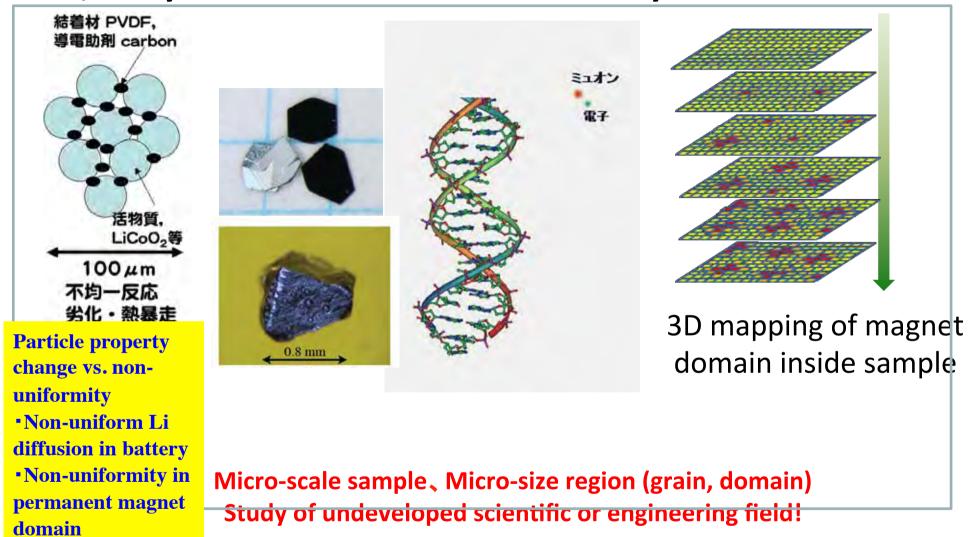
Ultraslow muon serves as a unique tool to probe the electronic state of subsurface and interface in the real space.

A01: Microbeam: Muon Microscopy, requiring only µg to ng sample



Realization of muon microscope

A01; Study of materials and life science by micro muon beam



Examples: Trans-uranium compound (Novel Np, Am compound etc.,)

Life science (Electron transfer in DNA etc.,)

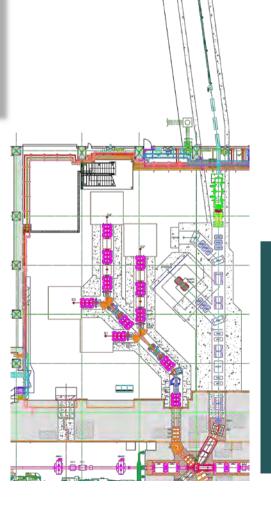
Industrial application (Inhomogeneity of reaction in Buttery compound etc.,)

S & H-Lines at MUSE

S-Line

Surface µ+

For material sciences



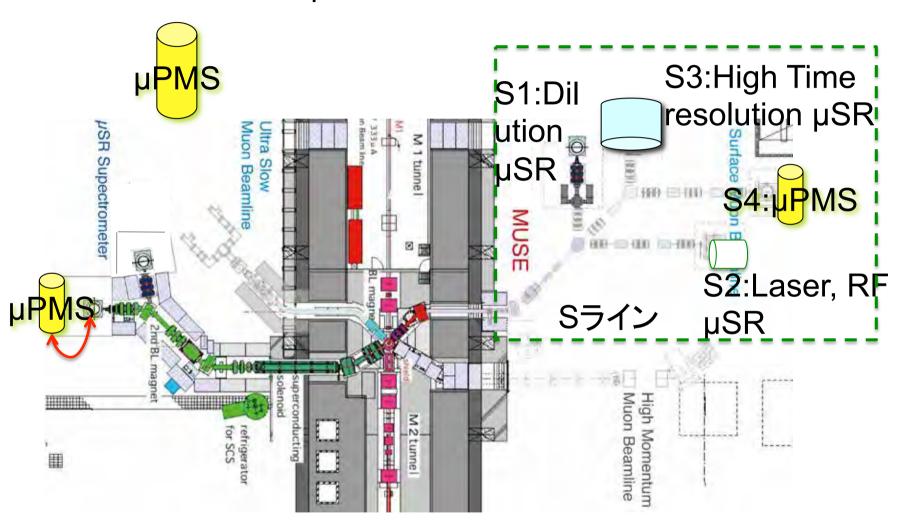
H-Line

Surface μ⁺ For HF, g-2 exp. e⁻ up to 120 MeV/c For DeeMe μ⁻ up to 120 MeV/c For μCF

Installation in the vicinity of production target @Summer, 2012

S-Line 「µSR利用拡

例:高速汎用装置「µPMS」…時間積分法で大強度を入れ活用



H-Line; Projects submitted to IMSS MUSE

OMU Hyperfine precise measurement(30MeV/c)

o"g-2"(30MeV/c)→Ultra Slow Muon:

Improve Sensitivity by x 100 (10⁻¹⁴)

Precision Measurement of Anomalous Magnetic Moment

Muon Precision Experiment to search for New Physics

<u>o"μ-e" Conversion(DeeMe) (105MeV/c)</u>:

Search for Charged Lepton Flavor Mixing

mprove Precision by x 5 (0.1 ppm)

Charged Lepton Flavor Mixing and Origin of Matter

○Pencil Beam Production(30MeV/c)

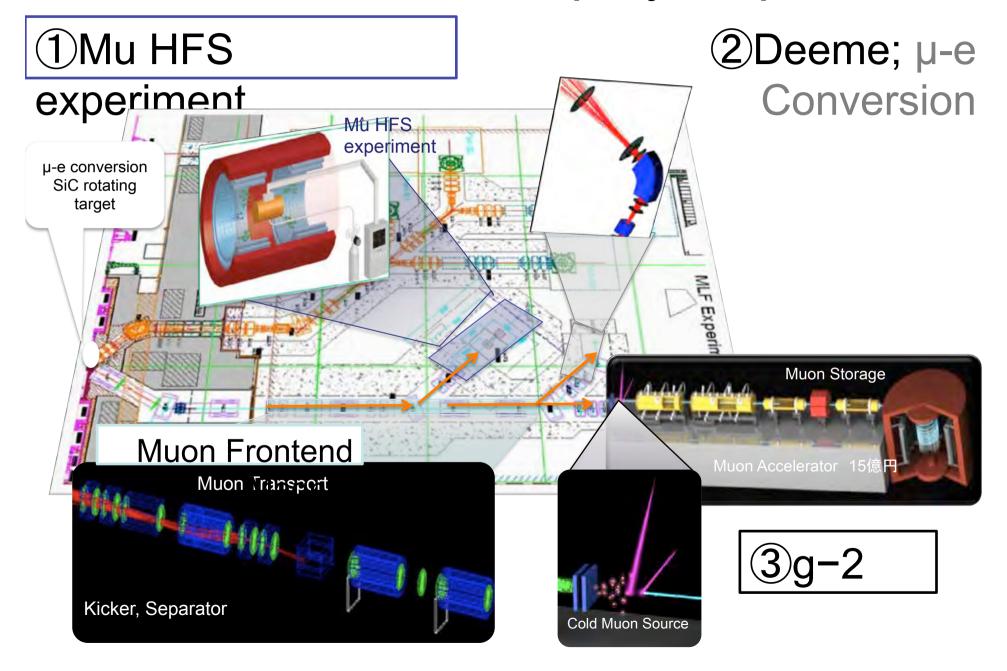
ouCF Under High Press. and Temp.(120MeV/c)

:For the experiments of μ CF high pressure and high temperature.

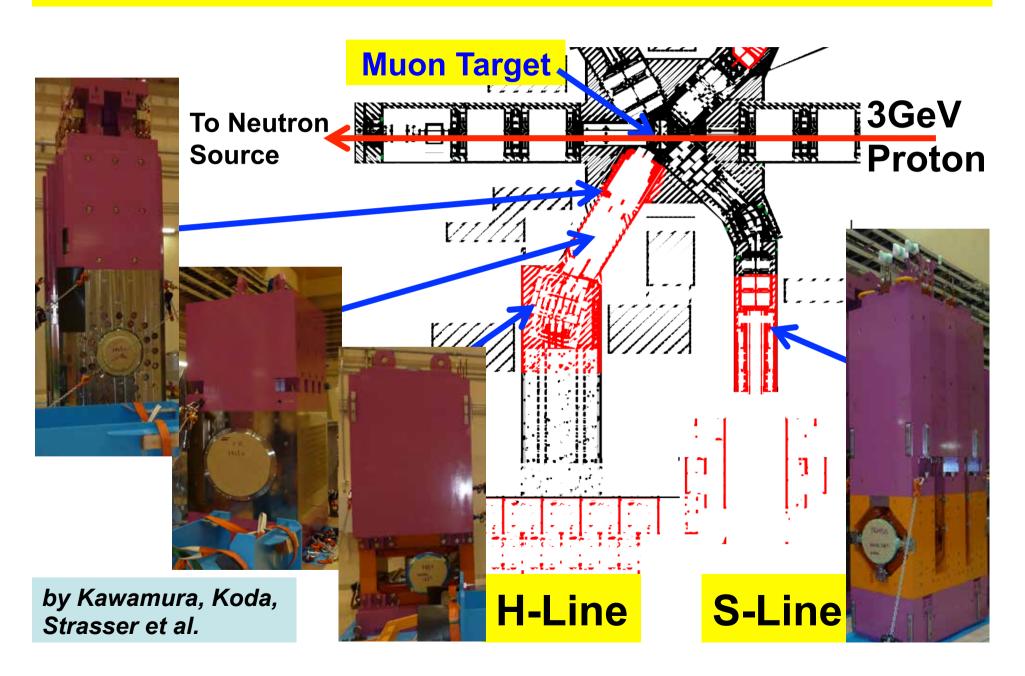
Welcome not only material sciences, but also fundamental physics!

Design H-Line extracting μ or e Up to 120 MeV/c

H-line Plan step by step



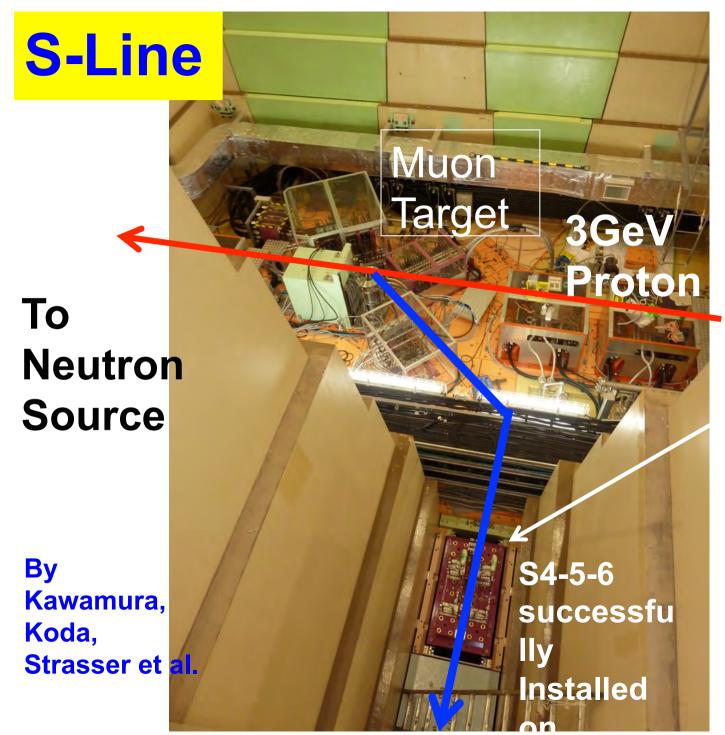
Installation of the Beam Line Components in the M2 tunnel this Summer, 2012



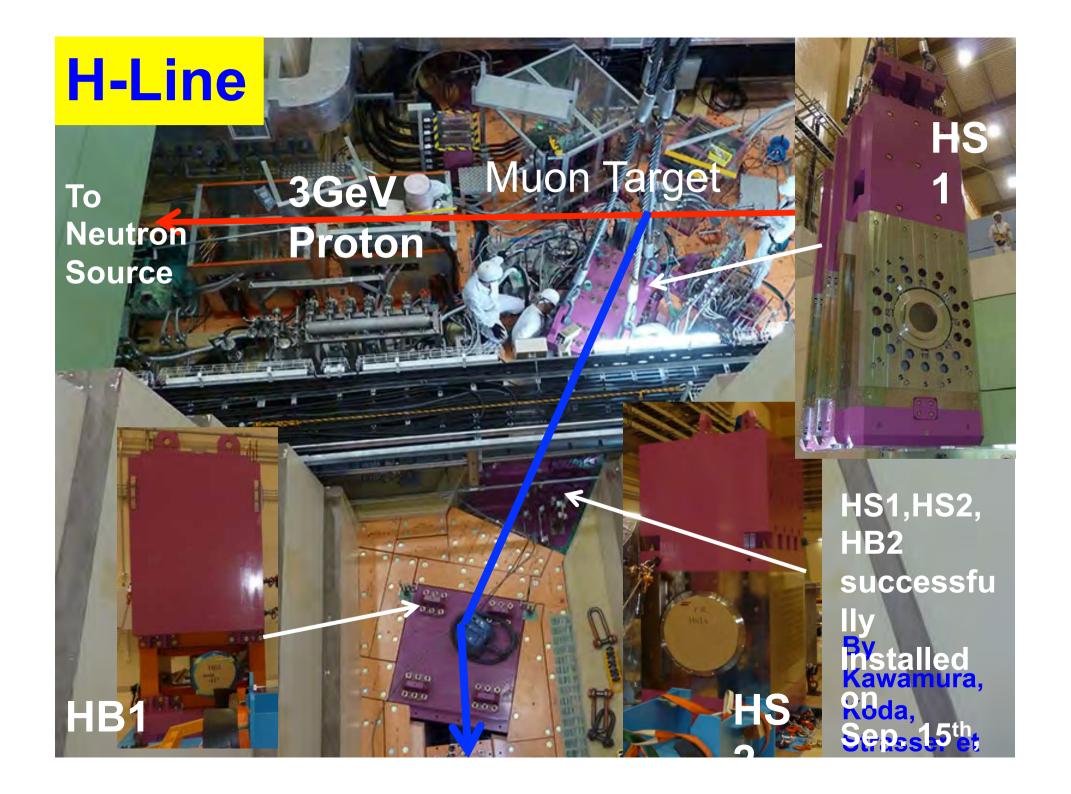
Summary

- (Muon Target, Operating well → Rotating Target!)
- D-Line, Operating User's Run → Kicker operation
- U-Line, Constructing now!
 +Grant-in-Aid (Innovative Areas)
- S-Line, Partially fabricated! → to KEK/MEXT!
 +Competitive Budget (Rare Earth Program?)
- H-Line, Partially fabricated! → to KEK/MEXT!
 +Grant-in-Aid (Kiban-S)

Welcome to J-PARC MUSE!



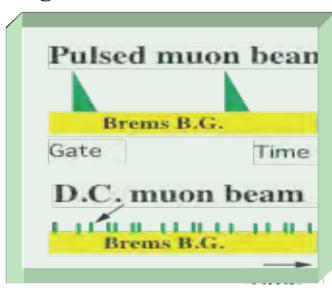




What is Pulsed Muon compared with DC Muon (Complementary)

- 1. Time Resolution is determined by proton beam, to be as large as 100 ns.
 - →Development of Beam Slicer
 - →Ultra Slow Muon Generation
- 2. Synchronization with pulsed perturbation
 - Can be synchronized with pulsed RF or Laser
 - →Ultra Slow Muon Generation by Laser Resonant Ionization of Mu
- 3. Long time Measurement (in particular, slow relaxation)
 - The higher intensity, the better, since no pile up occurs (μ decay or μ SR)
- 4. Phase Sensitive Measurement
 - Even under a large white noise, μ related signal can be observed efficiently, such as μ CF experiment under a large Bremstraulung from Tritium.
- 5. Instrument should be segmented!
 - →Expensive Spectrometer

Complementary to Continuous Beams



STEP1:Generation of themal Mu in vacuum From Mills et al. RELATIVE DELAYED COUNT RATE 0.16 Pu = 23.2 MeV/c (a) HOT" EVENTS/μsec/μ⁺ 10-2 1970≤T≤2290K 0.14 COLD 10-3 T≤1210K 0.12 26≤z ≤49 mm TIME (µ sec) 0.10 500 1000 1500 2000 2500 x10⁻³ HOT - COLD T (K) 5.0 •Z:Distance from hot 2.5 EVENTS $\cdot \exp(\lambda_0 t)/\mu \sec/\mu^+$ target, Mu takes more time 0.0 to reach further distance x10⁻³ 5.0 •About 4% of stopped 25 muons evaporate into 0.0 x10³ 5.0 (d) vacuum, as thermal Mu z=49mn 2.5

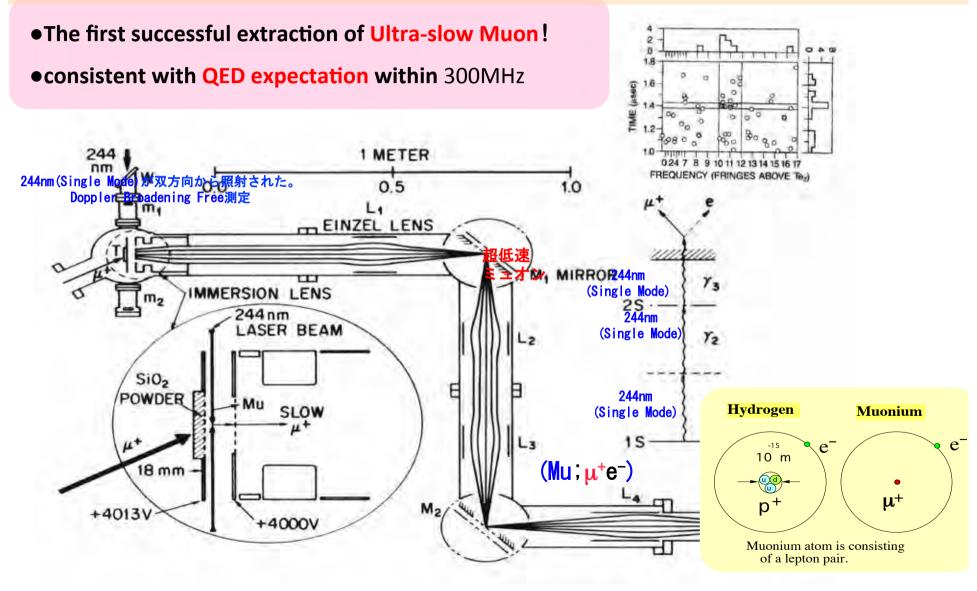
10

TIME (µ sec)

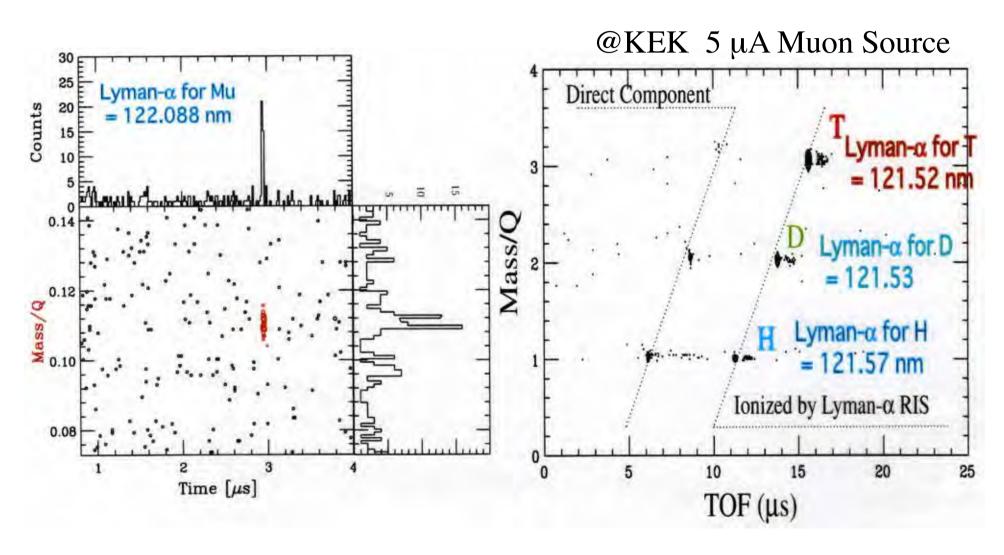
0.0

3000

STEP2: Resonant Ionization of thermal Muonium by 1s-2s excitation(~1987) (QED confirmation) By Chu, Mills, Kuga, Yodh, Miyake, Nagamine et al



STEP3:Generation of slow μ^+ and t^+ , d^+ , p^+ @KEK



Mu resonant ionization

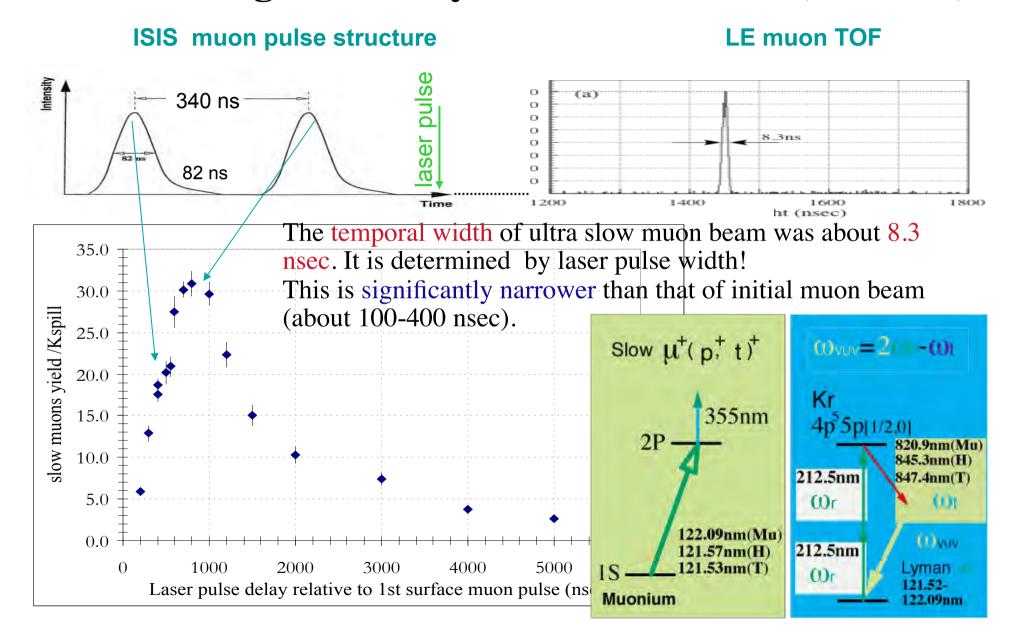
T,D, H resonant ionization

STEP4: Performance investigated through Preliminary Experiments held at RIKEN-RAL, **UK**

We established the way of Production target 800MeV proton beam line how to generate Ultra **Slow Muon by the** Port 3 **Resonant Ionization of Mu** at KEK, but Laser Cabin Pion injector **Muon Intensity at** Superconducting solenoid **KEK-MSL** was too low! Port 4 Cryogenic system DC separators From KEK, 2m We brought all the slow optics and Laser system to Port3 (RIKEN-RAL) in order to do R&D Port 2 efficiently! Port 1

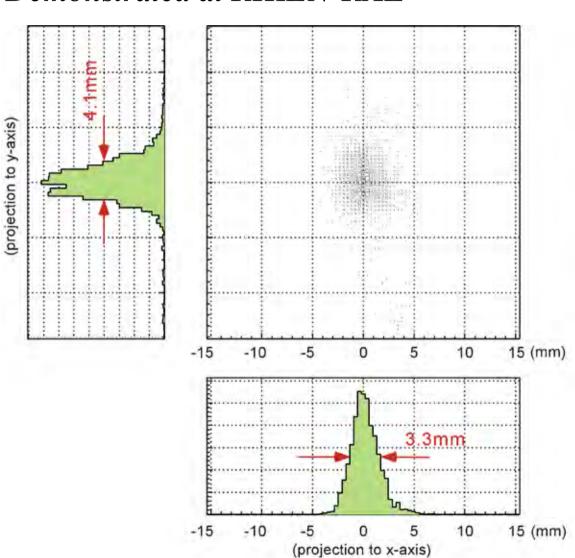
The RIKEN-RAL Muon Facility

STEP4: High Temporal Resolution (8.3 ns (Now we are using ns laser system to ionize Mu.) → 1 ns)



STEP4: Small Beam Size (\$\phi \sim 4 \text{ mm (Now)} \rightarrow \$\phi 1 \text{ mm}\$) → \$\phi 10 \text{ µm}\$ by accelerating 1MV at J-PARC

Demonstrated at RIKEN-RAL



The beam profile was measured by a position sensitive MCP at the sample position.

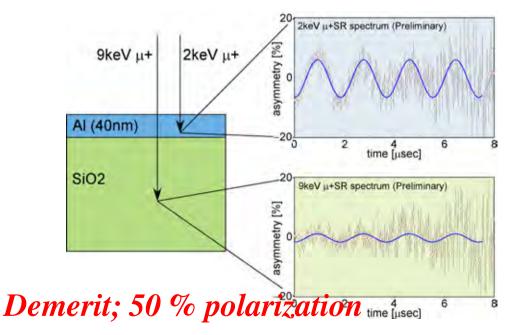
The beam width was 4.1mm (x-axis) and 3.3mm (y-axis) with 9.0keV beam energy.

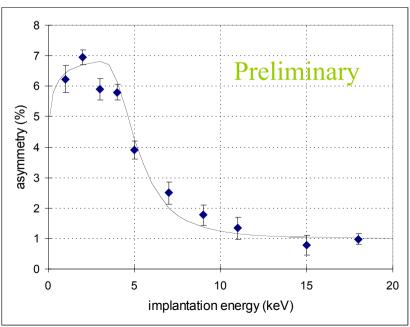
(The size of initial muon beam was about φ 50 mm at 4.1MeV beam energy.)

STEP4: Variable Implantation Depth (from 1 – 18 keV)

Demonstrated at RIKEN-RAL

- We have demonstrated that we can control muon's range within 10nm resolution by changing implantation energy from 1~18keV. (→ 0.05 -30 keV at J-PARC)
- → provides magnetic probe with depth resolution
- → application for study of surface/interfaces and multilayers





STEP4: Features of Ultra Slow Muon by Laser Resonant Ionization, featuring three kind of Shortening!

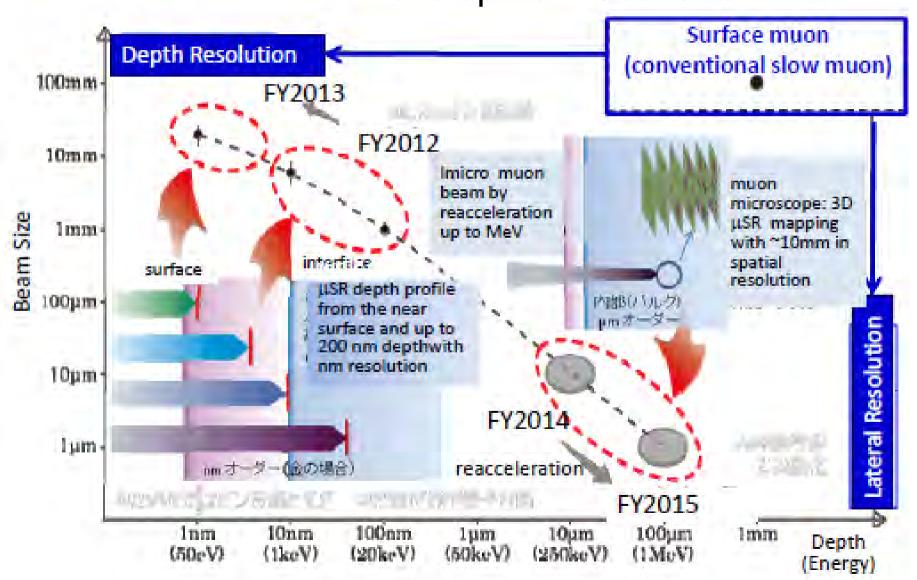
- 1. Variable Implantation Depth (~nm resolution)
- 2. Small Beam Size $(\phi \sim 4 \text{ mm (Now)} \rightarrow \phi 1 \text{ mm})$
- 3. High Temporal Resolution (8.3 ns (Now we are using ns laser system to ionize Mu.) \rightarrow 1 ns)
- 4. Synchronized with pulsed perturbation
- 5. Very Low Bg. --> Very small Relaxation

But, only 20 slow muons/s at RIKEN-RAL→J-PARC U-Line



Depth and Beam Size Scanned by Ultra Slow Muon Microscope

with Development Scenario



Comparison of features of slow muon beam obtained by the cryogenic moderator using solid Ne, or Ar and the laser resonant ionization

	Laser Resonant Ionization	Cryogenic Moderator (Ar, N ₂)
Muon Facility	J-PARC(<mark>U-LINE</mark>), KEK, RIKEN-RAL	PSI, TRIUMF
Beam Energy	0.05 - 30 keV -> 1 - 200 nm	0.5 - 30 keV -> 10 -200 nm
monochromacity	14 eV(before acceleration 0.2 eV)	400 eV
Beam Size	ϕ 1 mm> aiming at $\phi \sim \mu \text{m}$	ф 10 - 15 mm
Temporal resolustion	seveal sub ns ~ ns	~ 10 ns
Polarization	50% (100 % under 3 kG LF)	92%
Intensity	$20/s$ (RIKEN RAL), $\sim 10^{5-6}/s$ (J-PARC)	$10^{3-4}/s$
Synchronization	Possible (can be synchronized)	not possible

試料ホルダーを共通化、交換を容易に(試料の付け方などは個々の試料で検討) ロードロック機構 真空を壊さずに試料の移送と挿入を可能に

